

S.N. 10/708,433

**ELECTRONIC INFORMATION DISCLOSURE STATEMENT**

Electronic Version v18

Stylesheet Version v18.0

**Title of  
Invention**

Micromachined Capacitive RF Pressure Sensor

Application Number :

Confirmation Number:

First Named Applicant: Yunlong Wang

Attorney Docket Number:

Art Unit:


Examiner:

Search string: ( 6631645 or 6640642 or 5619476 or 5870351 or 5894452 or 6493288 ).pn

**US Patent Documents****Note: Applicant is not required to submit a paper copy of cited US Patent Documents**

init	Cite.No.	Patent No.	Date	Patentee	Kind	Class	Subclass
NO	1	6631645	2003-10-14	Satou , et al.	T0	73/718	0
	2	6640642	2003-11-04	Onose , et al.	T0	73/718	0
	3	5619476	1997-04-08	Haller , et al.	T0	367/181	0
	4	5870351	1999-02-09	Ladabaum , et al.	T0	367/163	0
↓	5	5894452	1999-04-13	Ladabaum , et al.	T0	367/163	0
NO	6	6493288	2002-12-10	Khuri-Yakub , et al.	T0	367/181	0

**Signature**

Examiner Name	Date
	3/8/05